

**RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE - EXAMINING GROUP 1720
PATENT**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Syuji Tsukamoto et al.
Application No. : 10/691,851
Filed : October 23, 2003
For : METHOD FOR CUTTING A PHOTORESIST-COATED
GLASS BOARD, CUTTING MACHINE FOR CUTTING A
PHOTORESIST-COATED GLASS BOARD AND
METHOD FOR MANUFACTURING AN OPTICAL
RECORDING MEDIUM

Examiner : Maria Alexandra Elve
Art Unit : 1725
Docket No. : 890050.442
Date : April 24, 2007

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR 1.116

Commissioner for Patents:

In response to the Office Action dated January 24, 2007, please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims that begins on page 2 of this paper.

Remarks begin on page 5 of this paper.